



520.34692V16

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: SORAOKA et al

Serial No.: 10/689,035

Filed: October 21, 2003

For: Vacuum Processing Apparatus And Semiconductor
Manufacturing Line Using Same

Art Unit: 3749

Examiner: K. O Malley

AMENDMENT

Mail Stop: Amemdment (Fee)
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

August 20, 2004

Sir:

This is in response to the Office Action mailed May 4, 2004, in connection with the above-identified application. The amendments are listed below and set forth on the following pages.

Amendments to the Claims; and

Remarks are included following the amendments.